

AF/2811

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Jifa Hao, et al.

Docket No.

90065.99R272/17732.6323

Serial No. 09/654,845	Filing Date September 1, 2000	Examiner Ori Nadav	Group Art Unit 2811
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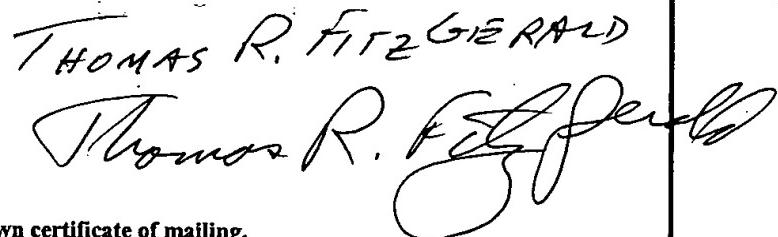
Invention: POWER SEMICONDUCTOR DEVICE WITH HIGH AVALANCHE CAPABILITY AND PROCESS FOR FORMING SAME

I hereby certify that this

AMENDMENT AFTER FINAL

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The
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